



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: **Jason M. Hendler, et al**

Art Unit: **2821**

Serial No.: **10/645,862**

Examiner: **Chen, Shih Chao**

Filed: **08/21/2003**

Confirmation No.: **7691**

Attorney Docket: **D026/069987-031**

For: **Apparatus and Method for Forming a Monolithic Surface-Mountable Antenna**

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

August 15, 2005

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

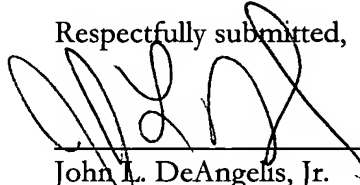
Dear Sir:

The Applicants submit the following comments relative to the Examiner's Statement of Reasons for Allowance in the above-identified patent application.

In his Statement, the Examiner identifies refers to certain claim elements as the primary reason for the allowance of the enumerated claims. The Applicants wish to note that the allowance of each claim was arrived at thorough a rigorous examination based on all elements of all claims. Further, each claim sets forth a different claim scope and thus may be allowable for reasons beyond the reasons stated by the Examiner.

The Applicants understand that the comments set forth herein will be placed in the file of the Patent and Trademark Office for this application.

Respectfully submitted,



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CERTIFICATE OF MAILING

I HEREBY CERTIFY that this Comments on Statement of Reasons for Allowance is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 15th day of August, 2005.



Pamela A. Pagel